

# WEST Search History

DATE: Tuesday, May 13, 2003

<u>Set Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
side by side			result set
<i>DB:USPT; PLUR: YES; OP:ADJ</i>			
L24	L23 and (oxide NEAR6 etch\$3)	127	L24
L23	L22 and (plasma ADJ etch\$3)	229	L23
L22	L21 and ("CF.sub.4" SAME nitrogen)	365	L22
L21	L20 and etch\$3.clm.	5268	L21
L20	"CF.sub.4"	10729	L20
L19	L18 and (CF4 SAME nitrogen)	8	L19
L18	L17 and nitrogen	77	L18
L17	L16 and (plasma ADJ etch\$3)	181	L17
L16	L15 and oxide	383	L16
L15	L14 and etch\$3	491	L15
L14	CF4	708	L14
L13	hexafluoro-ethane	15	L13
L12	tetrafluoro-methane	10	L12
L11	difluoro-methane	10	L11
L10	L9 and etch\$3	5	L10
L9	L8 and alkane	125	L9
L8	fluoro-substituted	865	L8
L7	fluoro-alkane	5	L7
L6	fluoro-alkane and etch\$3	2	L6
L5	L4 and (bump or ball).clm.	14	L5
L4	L3 and (bump or ball)	79	L4
L3	L2 and semiconduct\$3	1403	L3
L2	etching ADJ system	1779	L2
L1	BLM and (etching ADJ system)	0	L1

END OF SEARCH HISTORY